Docket No.: ATMI-567-DIV Customer ID No.: 25559

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Jose I. Arno

Title

: "INFRARED THERMOPILE DETECTOR SYSTEM FOR

SEMICONDUCTOR PROCESS MONITORING AND CONTROL"

U.S. Serial No.: New Divisional of Prior Copending U.S. Patent Application No.

Prior Application Filing Date: May 8, 2002

Prior Application Group Art Unit: 2812

Prior Application Examiner: Olivia T. Luk

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(Signature of person mailing paper or fee)

Mail Stop Patent Application Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

## PRELIMINARY AMENDMENT

Sir:

Prior to examining the instant application on the merits, please amend the

specification as follows: